



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 13, 2026	
IGI Report Number	LG771663663
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MIXED CUT
Measurements	10.02 X 7.35 X 4.73 MM

GRADING RESULTS

Carat Weight	2.82 CARATS
Color Grade	F
Clarity Grade	VVS 1

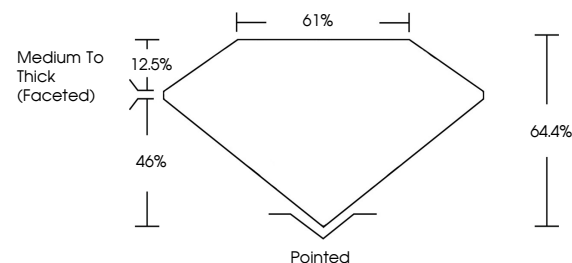
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	15 LG771663663

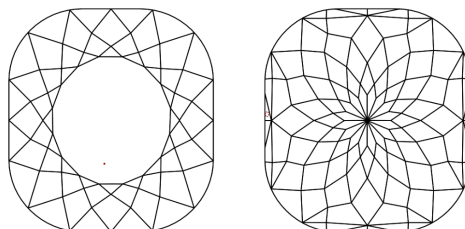
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG771663663
Report verification at igi.org

PROPORTIONS

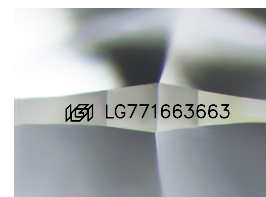


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

February 13, 2025	2.82 CARATS
GI Report No. LG77163563	F
CUSHION MIXED CUT	VVS 1
	64.4%
	61%
	Medium to Thick (Faceted)
	Pointed
	EXCELLENT
	VERY GOOD
	NONE
	gsm LG77163563

Comments: This is a Very Good Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa